

Docket Number MIT-114...	Application Number 09/898,815
Applicant Shi-Chang Wooh	
Filing Date July 5, 2001	Art Unit 2878

U.S. PATENT DOCUMENTS

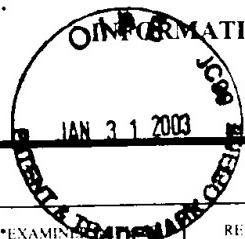
EXAMINER INITIALS SY	REF	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	FILING DATE IF APPROPRIATE
		6,382,028 B1	5/7/2002	Wooh et al.	
		6,360,609 B1	3/26/2002	Wooh	
		6,351,586 B1	2/26/2002	Krol et al.	
		6,324,912 B1	12/4/2001	Wooh	
		6,186,004	2/13/2001	Kaduchak et al.	
		6,067,391	5/23/2000	Land	
		5,801,312	9/1/1998	Lorraine et al.	
		5,760,904	6/2/1998	Lorraine et al.	
		5,698,787	12/16/1997	Parzuchowski et al.	
		5,684,592	11/4/1997	Mitchell et al.	
		5,634,936	6/3/1997	Linden et al.	

FOREIGN PATENT DOCUMENTS

REF	FOREIGN DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	Translation	
				YES	NO
SY	WO 99/44029 A1	9/2/1999	Wooh	✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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JAN 31 2003

Docket Number MIT-114J	Application Number 09/898,815
Applicant Shi-Chang Wooh	
Filing Date July 5, 2001	Art Unit 2878

U.S. PATENT DOCUMENTS

REF	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	FILING DATE IF APPROPRIATE
SY	5,608,166	3/4/1997	Monchalin et al.	
	5,549,003	8/27/1996	Drescher-Krasicka	
SY	5,457,997	10/17/1995	Naruo et al.	
SY	5,402,235	3/28/1995	Monchalin	
SY	5,353,512	10/11/1994	Theurer et al.	
SY	5,257,544	11/2/1993	Khuri-Yakub et al.	
SY	5,079,070	1/7/1992	Chaleo et al.	
SY	4,567,769	2/4/1986	Barkhoudarian	
SY	4,541,280	9/17/1985	Cielo et al.	
SY	4,523,469	6/18/1985	Scott et al.	
SY	4,512,197	4/23/1985	von Gutfeld et al.	

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Direct Number

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Applicant
Shi-Chang Wooh

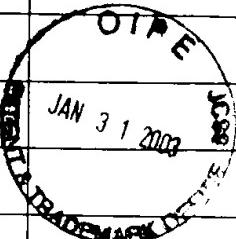
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